



PATENT  
Atty. Dkt. No. APPM/008629/FEP/GCM/AG  
Serial No.: 10/736,061

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

## Impact Application of: Olsen, et al.

Serial No.: 10/736,061

Confirmation No.: 4253

Filed: December 15, 2003

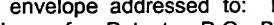
For: A Method of Forming a  
Silicon Oxynitride Layer

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 1762

Examiner: Cachet I. Sellman

<b>CERTIFICATE OF MAILING</b> <b>37 CFR 1.8</b>	
<p>I hereby certify that this correspondence is being deposited on  <u>5/8</u>, 2006 with the United States Postal Service as  First Class Mail in an envelope addressed to: Mail Stop  Amendment, Commissioner for Patents, P.O. Box 1450,  Alexandria, VA 22313-1450.</p>	
<u>5/8/06</u> Date	 Signature

**RESPONSE TO OFFICE ACTION DATED FEBRUARY 13, 2006**

In response to the Office Action dated February 13, 2006, having a shortened statutory period for response set to expire on May 13, 2006, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicants believe that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/008629/KMT for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Specification** begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper. **Remarks** begin on page 7 of this paper.